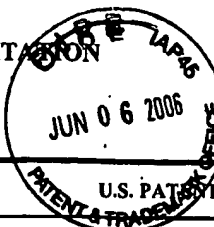


INFORMATION DISCLOSURE CITATION

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Docket Number (Optional)

YOR920010496US1

Application Number

10/091,515

Applicant(s)

Hobbes, et al.

Filing Date

March 7, 2002

Group Art Unit

2874

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

8/18		Wilke et al. , "Nanometer Thin-Film Ni-NiO-Ni Diodes for 30 THz Radiation", pages 329-341 <i>Applied Physics A</i> 58 (1994).
8/18		Fumeaux et al., "Mixing of 30 THz laser radiation with nanometer thin-film NI-NIO-Ni diodes and integrated bow-tie antennas, pages 135-140 <i>Applied Physics B</i> 63 (1996)

EXAMINER

Sarah Nelson

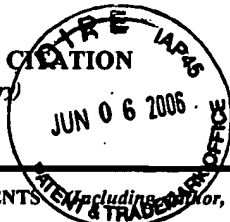
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INITIAL

OTHER DOCUMENTS

(Including Prior Art, Title, Date, Pertinent Pages, Etc.)

"ac electron tunneling at infrared frequencies: Thin-film M-O-M diode structure with broad-band characteristics";
Applied Physics Letter, Vol. 24, No. 6, March 15, 1974, Small et al., pp 275-279.

EXAMINER

DATE CONSIDERED

Sarah V. Long

28 AUG 06

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